



INTERNATIONAL ATOMIC ENERGY AGENCY
UNITED NATIONS EDUCATIONAL, SCIENTIFIC AND CULTURAL ORGANIZATION
INTERNATIONAL CENTRE FOR THEORETICAL PHYSICS
I.C.T.P., P.O. BOX 586, 34100 TRIESTE, ITALY, CABLE: CENTRATOM TRIESTE



UNITED NATIONS INDUSTRIAL DEVELOPMENT ORGANIZATION



INTERNATIONAL CENTRE FOR SCIENCE AND HIGH TECHNOLOGY

c/o INTERNATIONAL CENTRE FOR THEORETICAL PHYSICS 34100 TRIESTE (ITALY) VIA GRIGNANO, 9 (ADRIATICO PALACE) P.O. BOX 586 TELEPHONE 040/224972 TELEFAX 040/224973 TELEX 40049 IAPN I

H4.SMR/676-19

**SECOND SCHOOL ON THE USE OF SYNCHROTRON
RADIATION IN SCIENCE AND TECHNOLOGY:
"JOHN FUGGLE MEMORIAL"**

25 October - 19 November 1993

Miramare - Trieste, Italy

Instrumentation for X-Ray Spectrometry

OPTICS

H. Tolentino
National Laboratory for Synchrotron Radiation
(LNLS)
Campinas, Brazil

instrumentation for X-ray spectrometry

optics

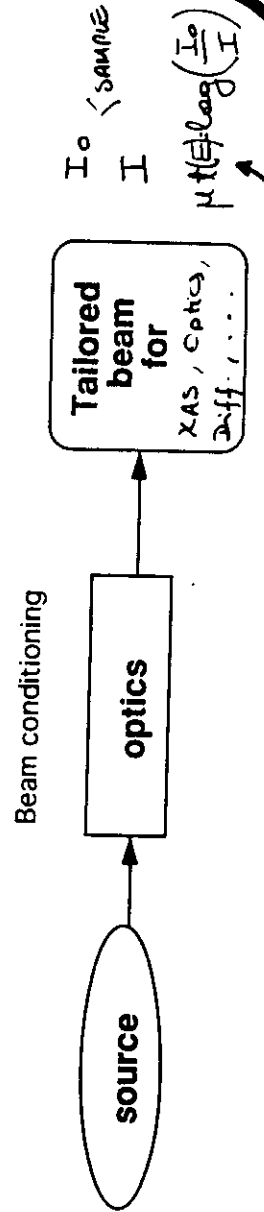
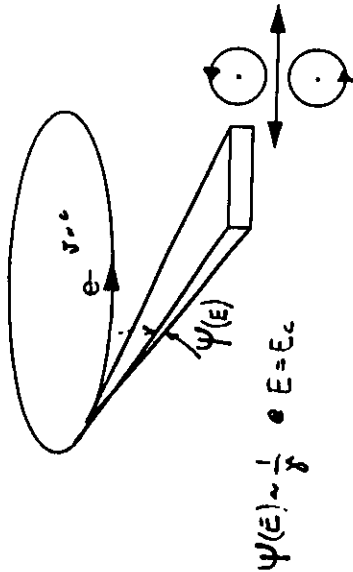
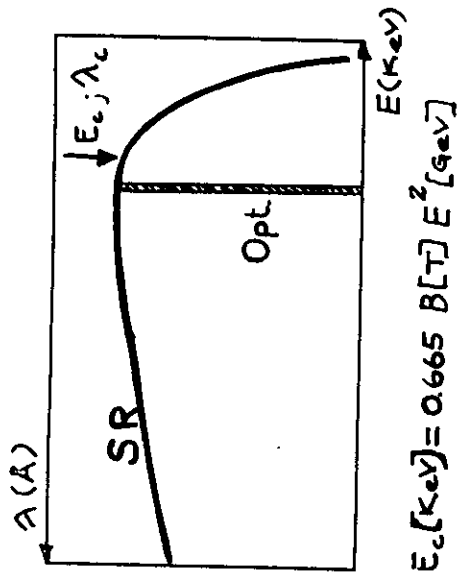
needs : x-ray source
optics
detectors
specific needs

optics

beam shapers
mirrors
monochromators

new trends

high brilliance sources
state of polarization
high resolution



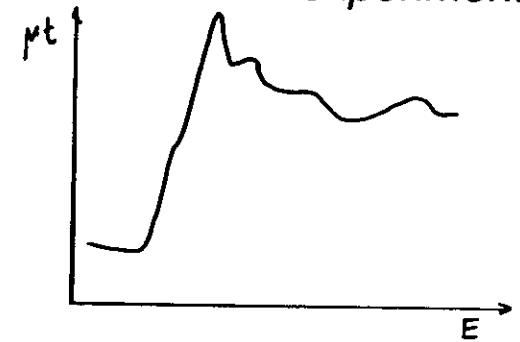
x-ray optical system

beam characteristics
sample conditioning
detection scheme

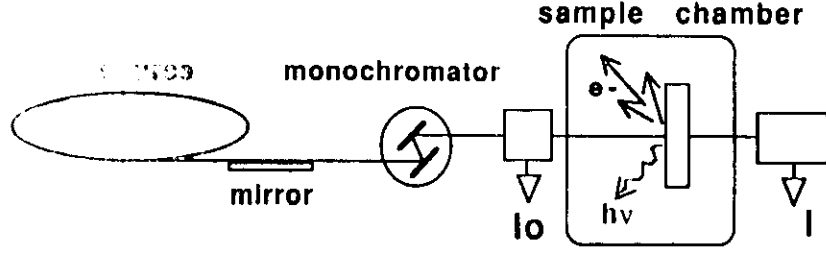
to transform the beam to match it to the experiment

XAS requirements

- o energy range
- o energy tunability
- o energy resolution
- o harmonic purity
- o polarization state
- o intensity / stability
- o signal / noise
- o focusing possibilities
- o high mechanical precision, stability and reproducibility



XAS workstation



$$R = 1 - \frac{I}{I_0}$$

Transmittance

$$\delta = \left(\frac{r_0}{2\pi} \right) N f(0) \lambda^2$$

$$\delta \sim 10^{-5}$$

$$n < 1$$

Snell's law

$$\cos \theta_2 = n \cos \theta_1$$

$$\cos \theta_1 = (1 - \delta)$$

$$1 - \frac{\theta_1^2}{2} = 1 - \delta$$

$$\theta_c = 2.34 \times 10^{-3} \sqrt{\frac{Z\rho}{A}} \lambda$$

$$\theta_c = \sqrt{2\delta} \propto \lambda$$

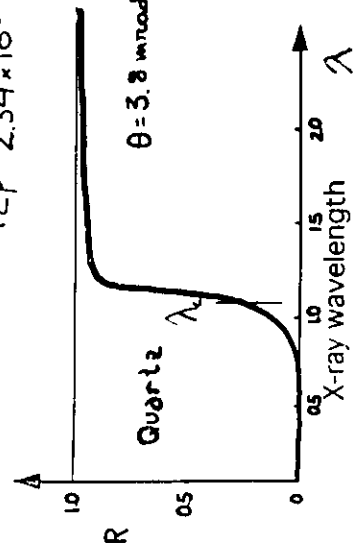
$$\delta \sim 10^{-5} \quad \theta_c \sim 1 \text{ mrad}$$

High-pass wavelength filter



Low-pass energy filter

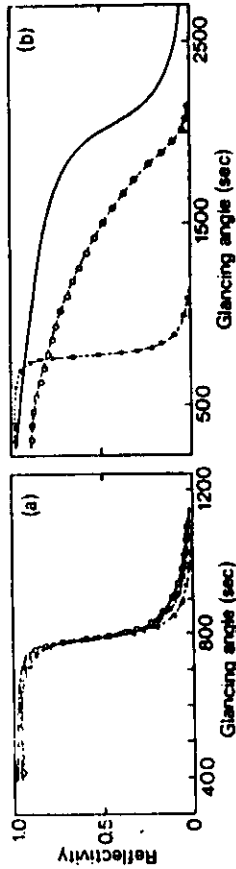
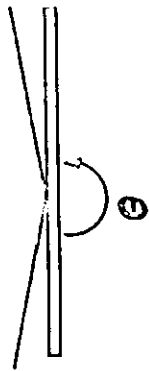
$$\lambda_c = \sqrt{\frac{A}{Z\rho}} \frac{\theta}{2.34 \times 10^{-3}}$$



$$\theta_c \approx 33 \text{ mrad} \quad \text{Cu}$$

$$\theta_c \approx 77 \text{ keV} \quad \text{Cu}$$

$$\lambda = 2.54 \text{ \AA}$$



Low-pass energy filter : HARMONICS ~~2051~~

Slit



Thermal load : the POWER is spread over a large area

Focusing element :
focus

match the DIVERGENCE of the beam to the ACCEPTANCE of the crystal



focusing mirrors

efficiency is determined by aberrations
and imperfections

o focusing geometry

meridional

sagittal

o accuracy and roughness

o thermal load

o figure error

BRAGG DIFFRACTION

multilayers

layered synthetic microstructures

o flexibility

o Bragg's law

o layers of high and low Z

stability

interdiffusion

interface roughness

layer thickness

o reflectivity

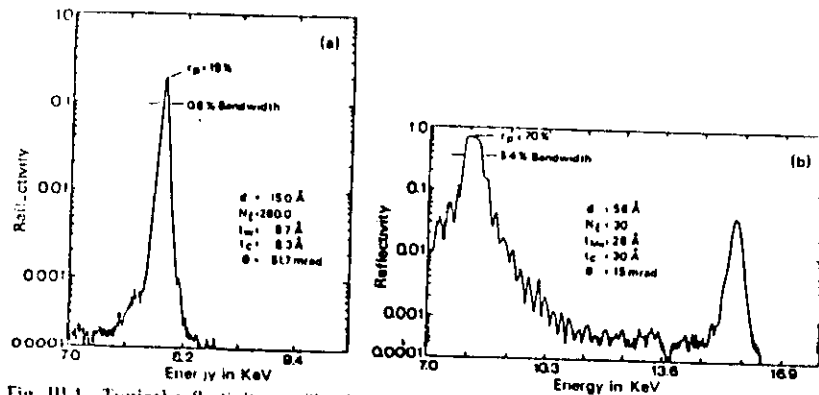
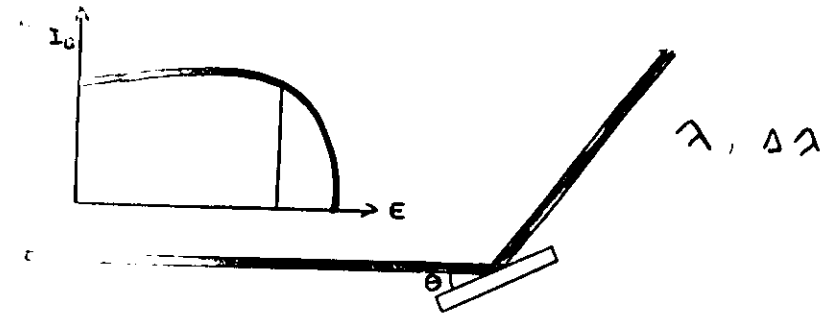


Fig. III.1.- Typical reflectivity profile obtained with multilayers (After Bilderback et al., 1993).

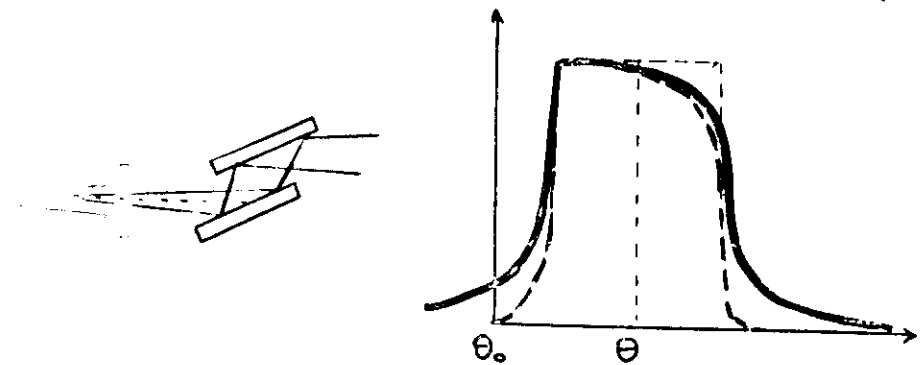


$$n \frac{\lambda}{L} = 2 d_{hkl} \sin \theta \left(1 - \frac{\delta(\lambda)}{\sin^2 \theta} \right) ; n = 1 - \delta - i\beta$$

$$\frac{\Delta \lambda}{\lambda} = \cot \theta \Delta \theta \quad \leftarrow \begin{matrix} \alpha \\ \Omega_D \propto \delta \propto \lambda^2 z \end{matrix}$$

$$\Omega_D \cot \theta \propto \frac{1}{h^2 + k^2 + l^2}$$

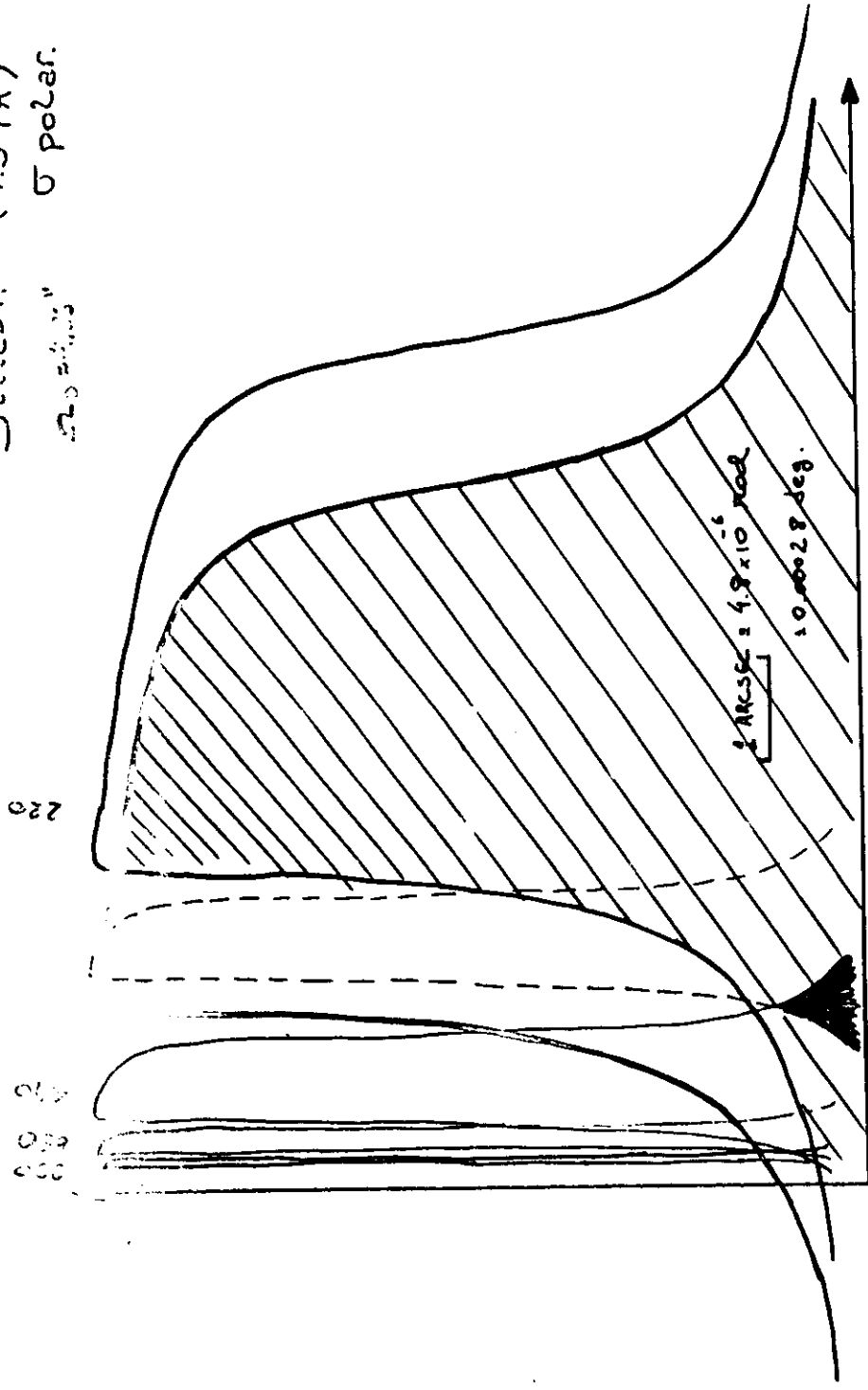
Fig.



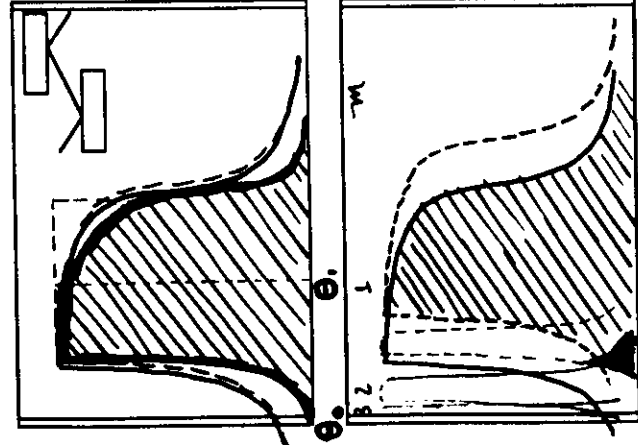
RESOLUTION & INTENSITY

$$S(\theta, \lambda) \downarrow \Omega_D \uparrow G_e(\theta, \lambda)$$

Silicon (1.54 Å)
 σ polar.



Dynamical theory of perfect crystals

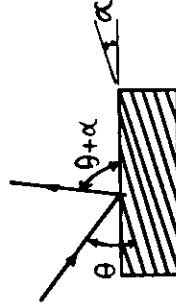


- $m \lambda = 2 d_{hkl} \sin \theta \quad (1 - \delta / \sin^2 \theta)$
- $n = 1 - \delta - \lambda \beta$
- $\Omega_s \propto \delta \propto \lambda^2 Z$
 $\Omega_p \cot \theta \propto \frac{1}{k^2 + k'^2 + l^2}$ RESOLUTION
- $\Delta \theta_0 \propto \lambda^2 Z$
- HARMONICS ($m > 1$)
 $\rightarrow$ DETUNING
 $\rightarrow$ MIRROR

• ASYMMETRIC CRYSTAL

$$\Omega_A = \delta_A \Omega_D \quad \delta_A = \sqrt{\frac{\sin(\theta - \alpha)}{\sin(\theta + \alpha)}}$$

RESOLUTION $\leftrightarrow$ ACCEPTANCE



Asymmetric crystal

$$\chi_A = \sqrt{\frac{\sin(\theta - \alpha)}{\sin(\theta + \alpha)}}$$

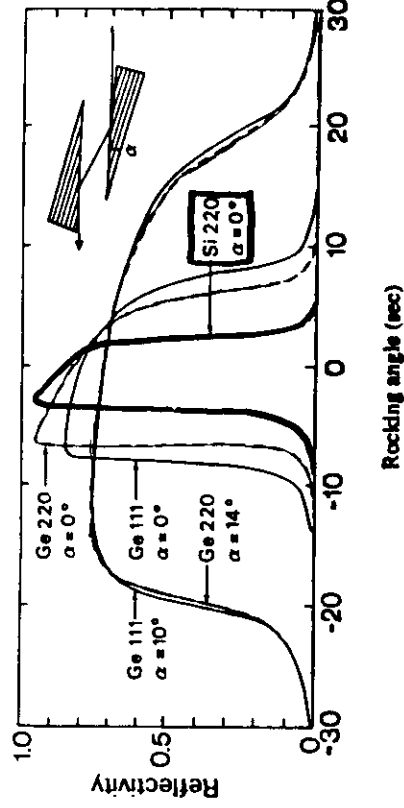


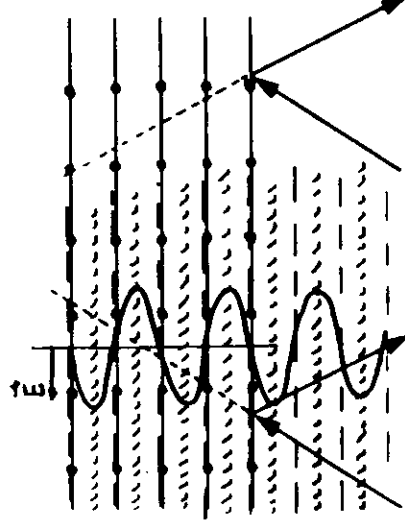
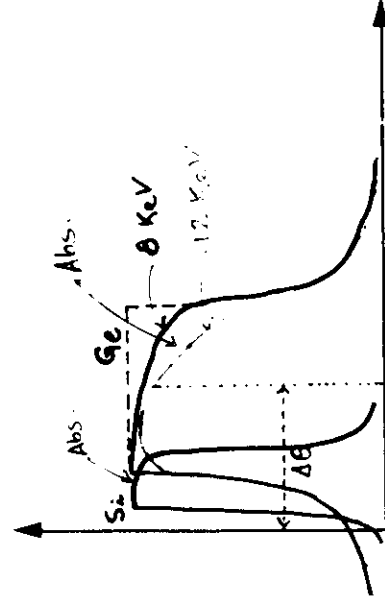
Fig. 6. Calculated double-reflection curves of grooved monochromators for symmetric and asymmetric reflections of silicon and germanium and for X-rays of 1.54 Å wavelength (After Kohra et al., 1978).

$$\Omega_A = \chi_A \Omega_D$$

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Absorption

$$n = 1 - \delta - i\beta$$



8 K eV Si(111) $\Omega = 7.4$ arcsec
 Ge(111) $\Omega = 16.6$ arcsec

≈ 1.1 eV
 ≈ 2.6 eV

Si : 1 s 1840 eV
 Ge : 1 s 11100 eV

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Primary Extinction

WITHIN THE RANGE OF TOTAL REFLECTION $\therefore \Omega$
THE ENERGY OF THE PRIMARY BEAM IS

WHOLLY DIVERTED INTO THE REFLECTED BEAM

* PRIMARY BEAM DIMINISHES RAPIDLY IN INTENSITY
 $\leadsto$ LARGE ABSORPTION COEFFICIENT

PRIMARY EXTINCTION (DARWIN) : NO ORDINARY ABSORPTION

$$\ell_{ext} = \frac{1}{N|f(2\theta)|r_0 \lambda^2}$$

$$t_{ext} = \frac{1}{N|f(2\theta)|r_0 2d \cos \theta}$$



$$t_{abs} = \frac{\sin \theta}{2\mu} \quad t_{ext} \ll t_{abs} \quad \text{e.g.: Si (111) } t_{ext} \quad t_{abs} (\mu m)$$

Si (111)	1.53	8.7
Ge (111)	0.68	2.94

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RESOLUTION

$$\lambda = 2d \sin \theta$$

$$\frac{\Delta \lambda}{\lambda} = \frac{\Delta E}{E} = \left[\left(\frac{\Delta d}{d} \right)^2 + (\Delta \theta \cot \theta)^2 \right]^{1/2}$$

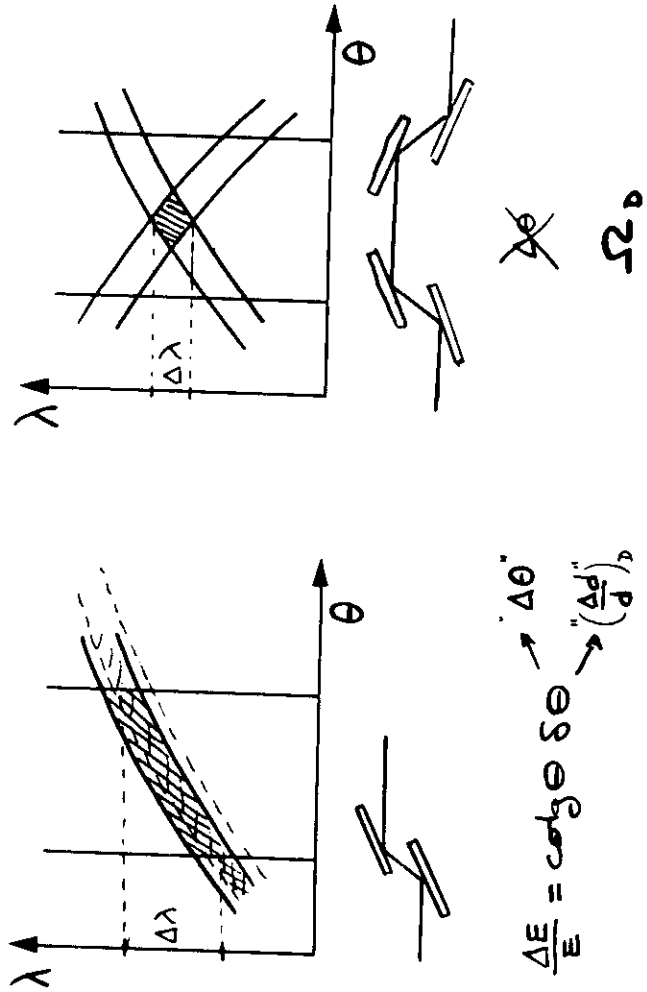
$\Delta \theta$: ANGULAR DISTRIBUTION $\otimes$ MOSAIC STRUCTURE

$\frac{\Delta d}{d}$: DIFFRACTION PATTERN P.C. $\otimes$ STRAINS AND VARIATIONS d
 $\downarrow$
 Ω_D

$$\Omega_D = \left(\frac{\Delta d}{d} \right)_D \tan \theta \quad \left(\frac{\Delta d}{d} \right)_D = \frac{\Delta \lambda}{\lambda} = \frac{4d}{\pi} N|f(2\theta)|r_0 \cos \theta = \frac{2d}{\pi t_{ext}}$$

$$\left(\frac{\Delta d}{d} \right)_D = 0.64 / N_P \quad N_P = \frac{t_{ext}}{d}$$

$\Omega_D \cot \theta$: RELATIVE ENERGY RESOLUTION WITH PERFECT CRYSTAL
WITH PARALLEL "WHITE" BEAM



single crystal monochromators for XAS

1 crystal :

focusing
high flux
dispersive

2 crystals :

several applications
flux & resolution
focusing
cooling

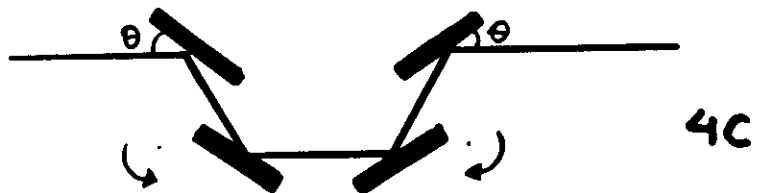
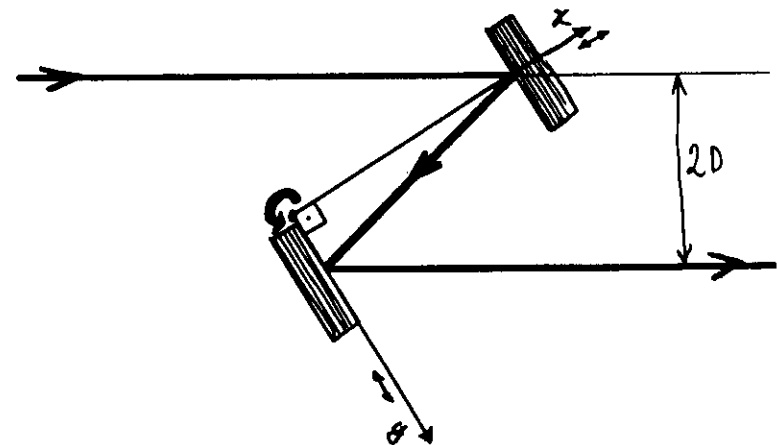
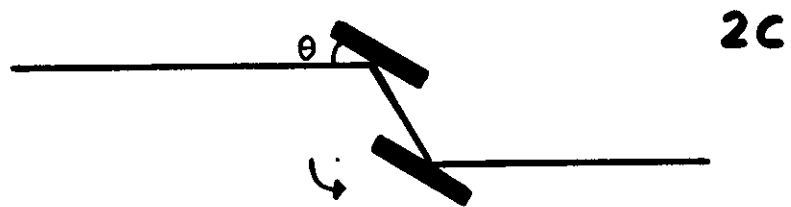
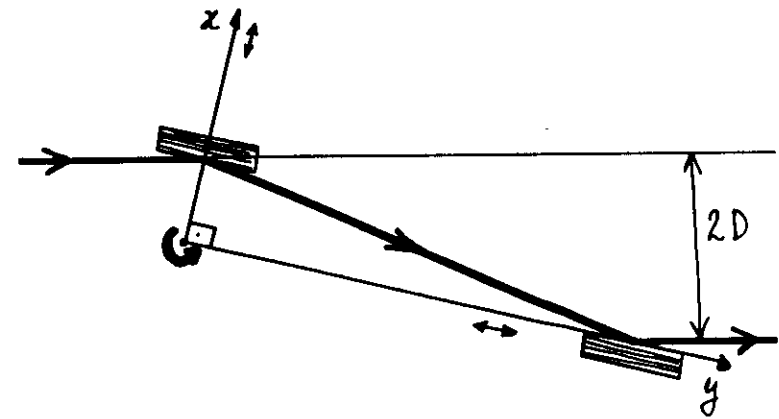
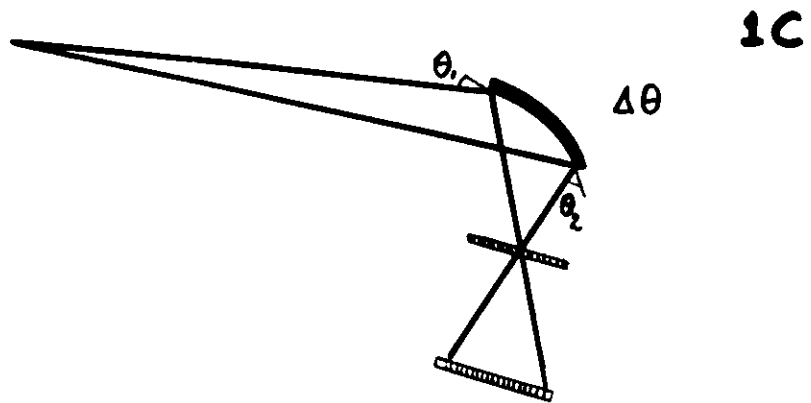
4 crystals :

high resolution
high collimation

backdiffraction :

high resolution
large angular acceptance

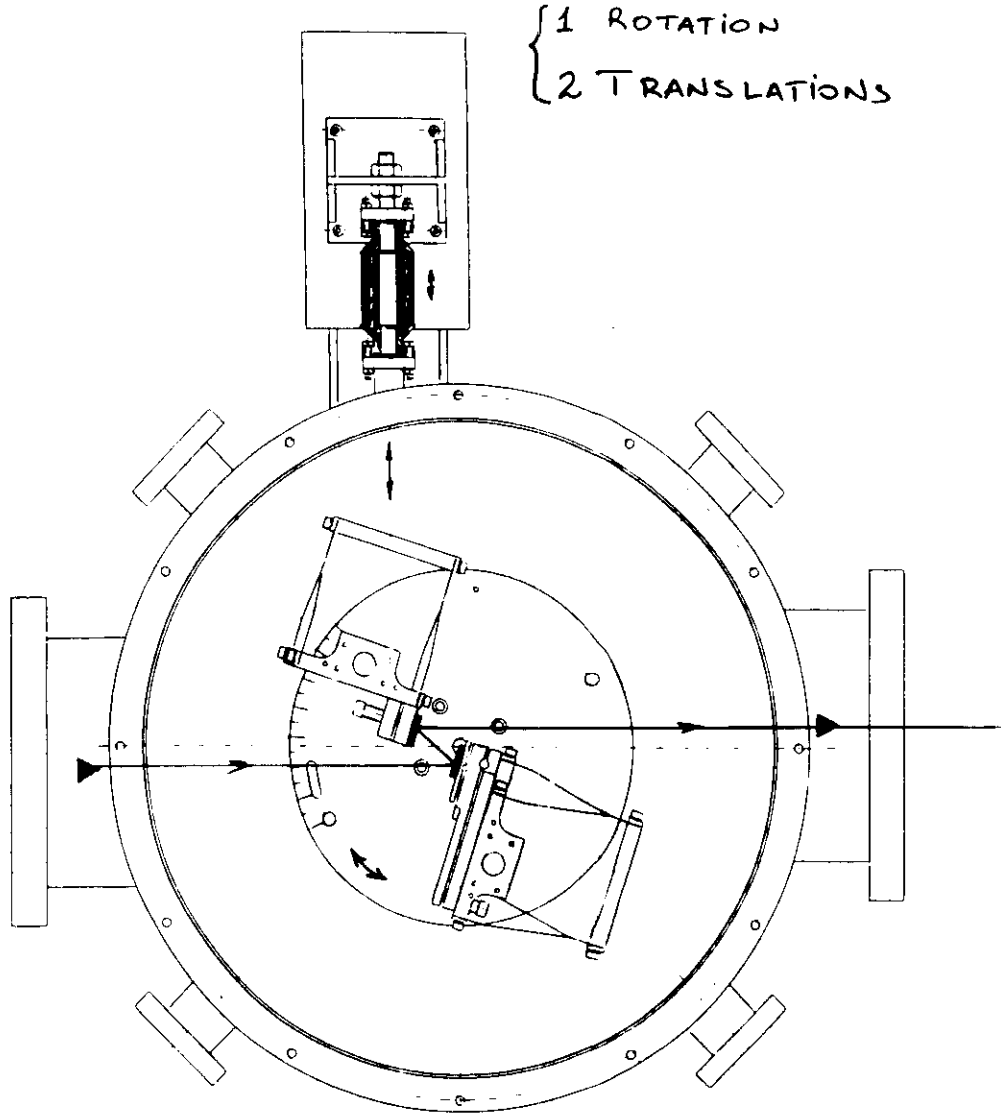
high flux



$$x = \frac{D}{\cos \theta}$$

$$y = \frac{D}{\sin \theta}$$

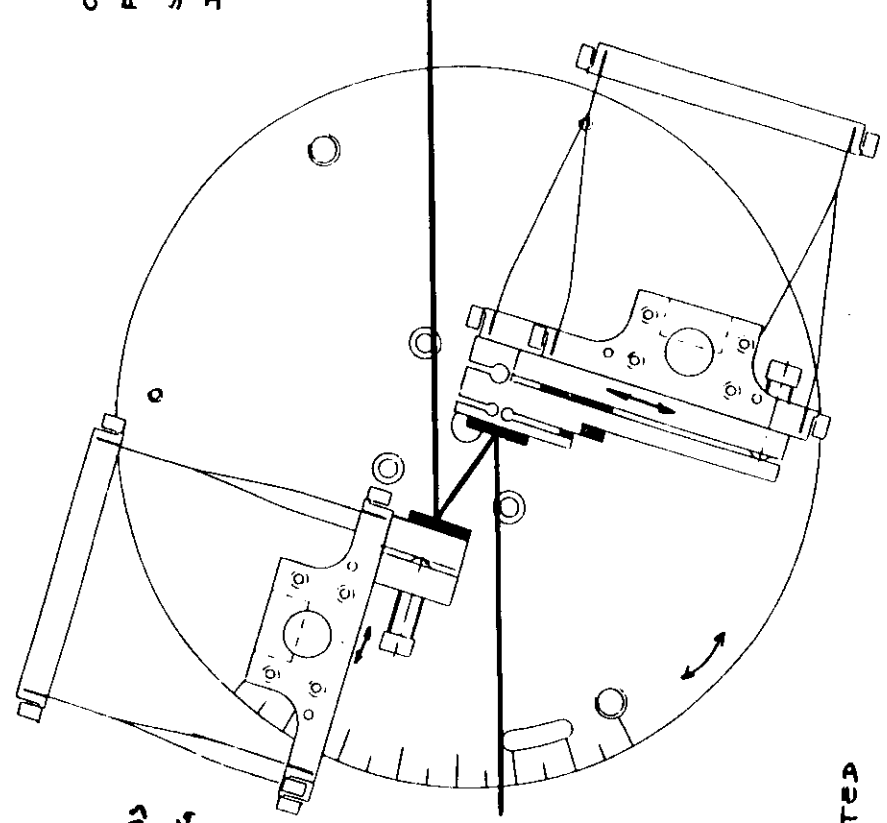
Two Crystal Monochromator using Elastic Translators



- 1 ROTATION
- 2 TRANSLATIONS

CUSATIS & GILES,
IN WORKSHOP SYNC. LIGHT

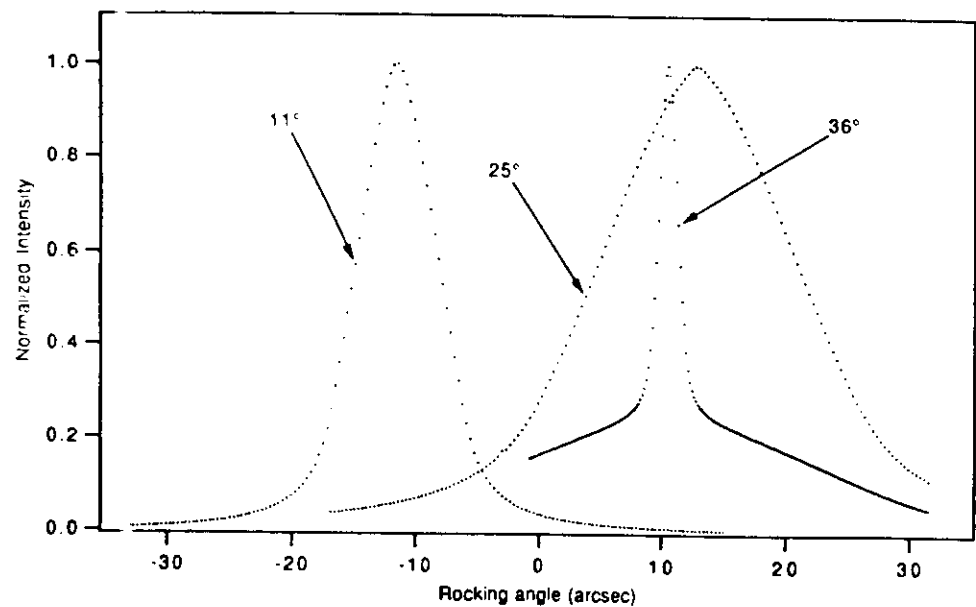
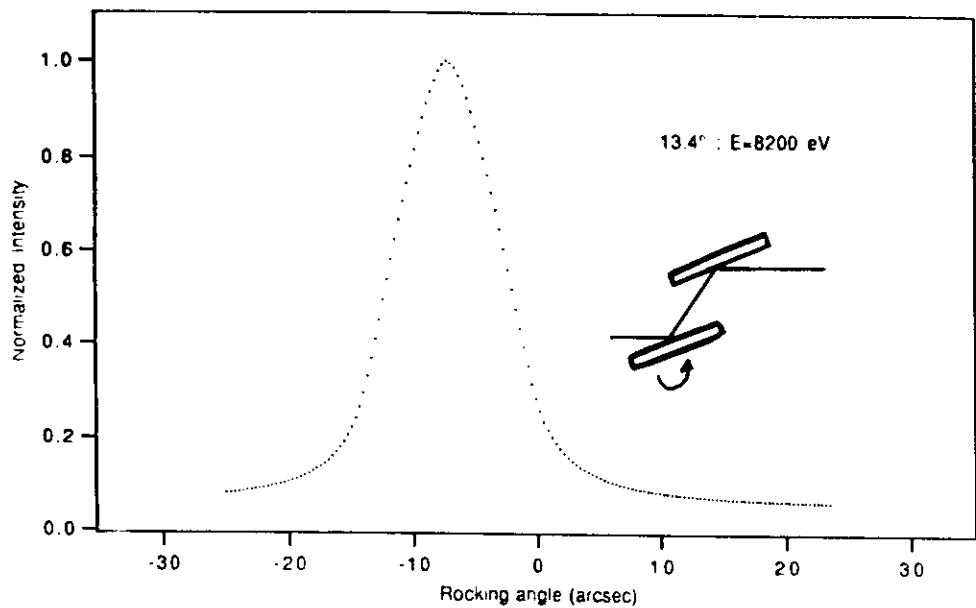
TWO-CRYSTAL MONOCHROMATOR WITH ELASTIC TRANSLATORS



- 1 ROTATION
- 2 TRANSLATIONS
- ELASTIC DETUNING
- MAGNETIC COIL

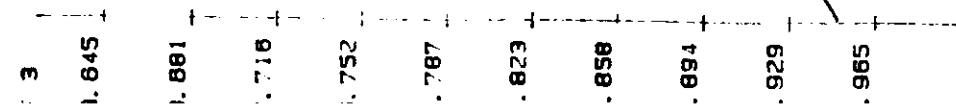
- CONSTANT OFF-SET
- FIXED BEAM POSITION
- SMALL DEAD-TIME
- DETUNING

- TRANSLATORS
- SMALL ERROR
- REPETITIVE
- DYNAMICALLY CORRECTED



redac : rc64, 65, 103 redac : rc 51

Measuring Stability

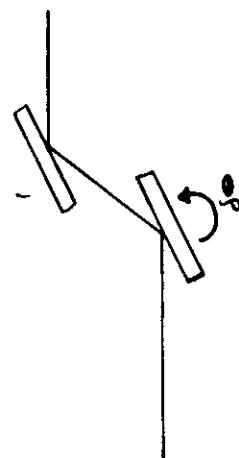


$\theta = 36^\circ$

Si(111) $\rightarrow$ 33611 eV

Si(333) $\rightarrow$ 10091 eV

RC11



1.8"

2.92"

0.409 0.818 1.227 1.636 2.045 2.454 2.863 3.272 3.681 4.090 E 3

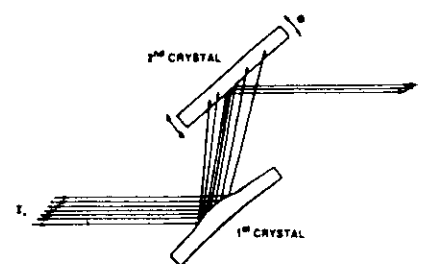
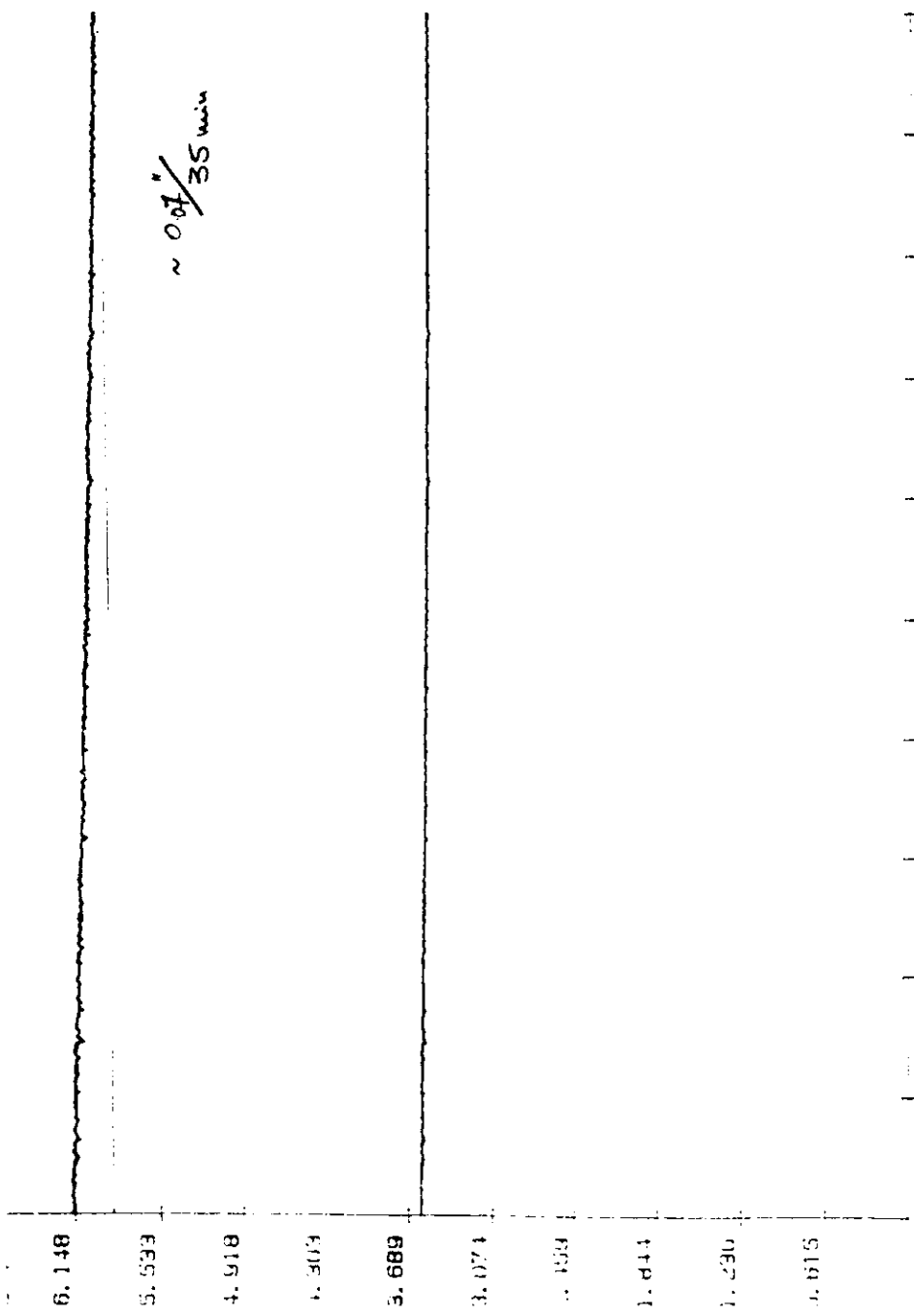


Figure 2 Schematic of the hot optics problem. The thermal bump on the first crystal's surface produced by the powerful incident beam spreads out the diffracted rays so that they do not simultaneously diffract from the 'cold' second crystal, entailing a loss of throughput.

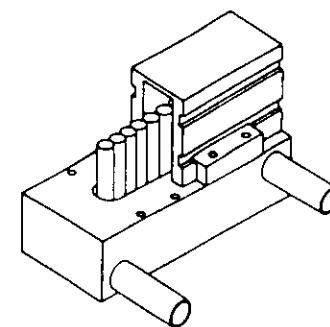


Figure 3 Geometric view of the monochromator and jet cooling manifold

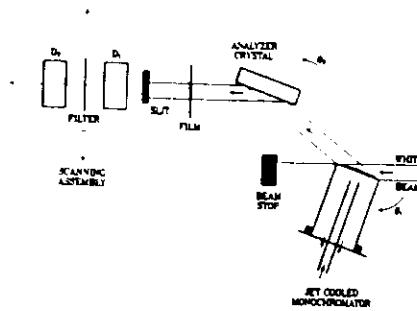


Figure 4 Double crystal experimental arrangement used at X25 to study thermal strains in the water cooled crystals. The double-crystal diffracted intensity for the fundamental reflection is measured with the ionization chamber D_1 , and the first harmonic is measured with D_2 .

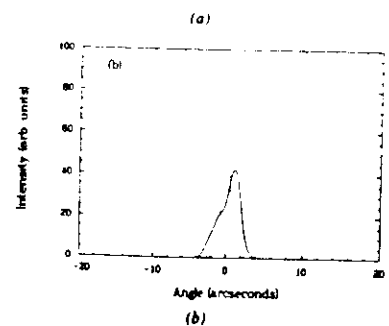
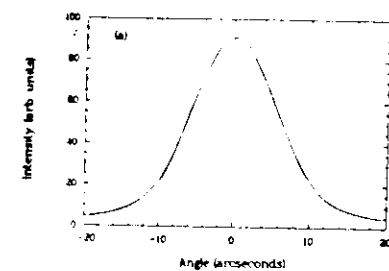


Figure 5 Rocking curves obtained at 175 mA beam current, for (a) the (111) reflection at 6.17 keV and (b) the simultaneous (333) reflection at 18.51 keV. The solid (—) curves are experimental, and the dashed (---) ones were derived from theory.

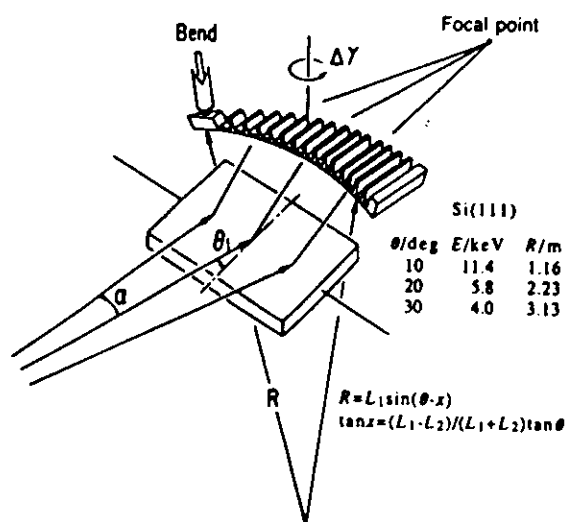
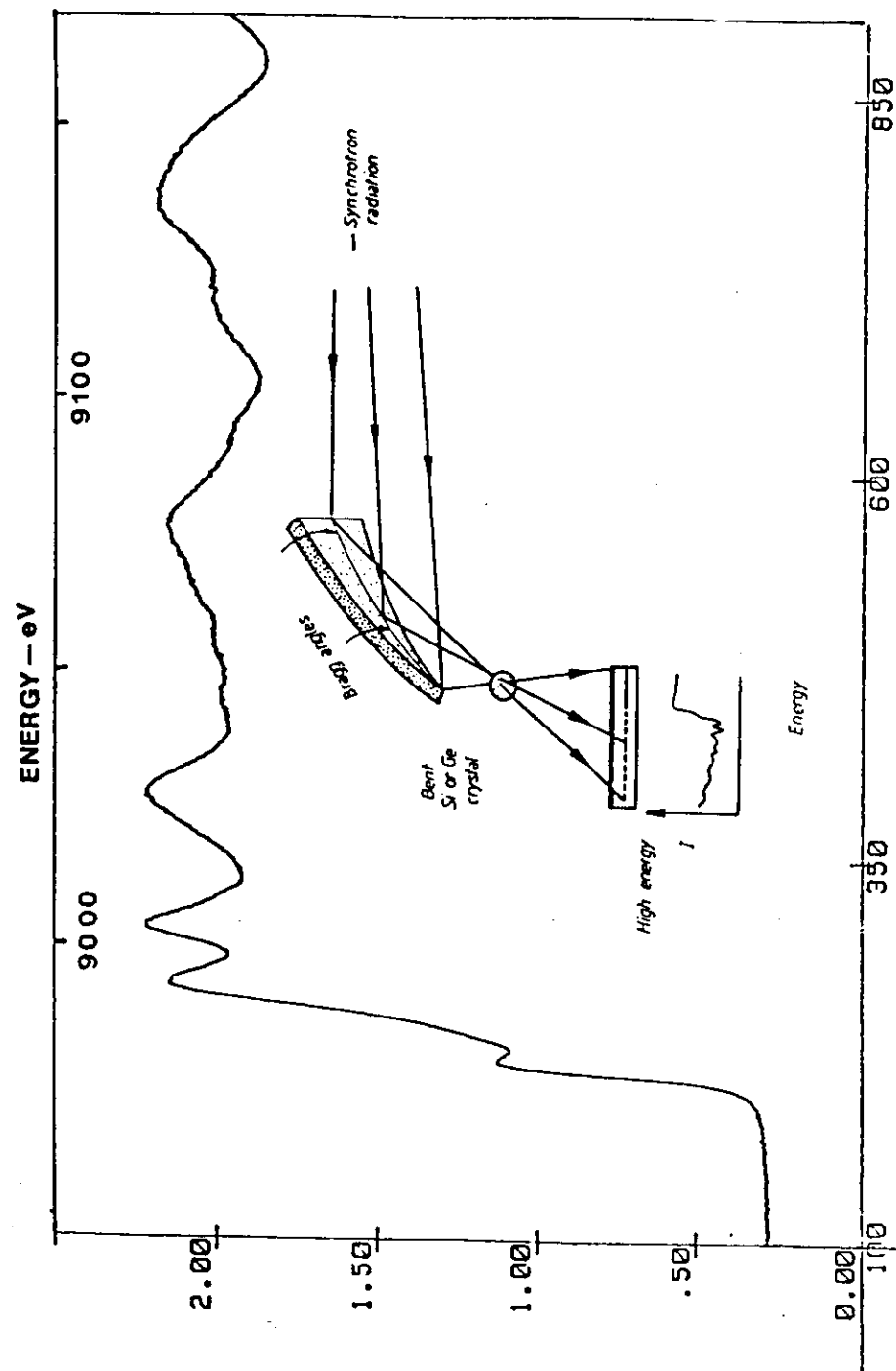
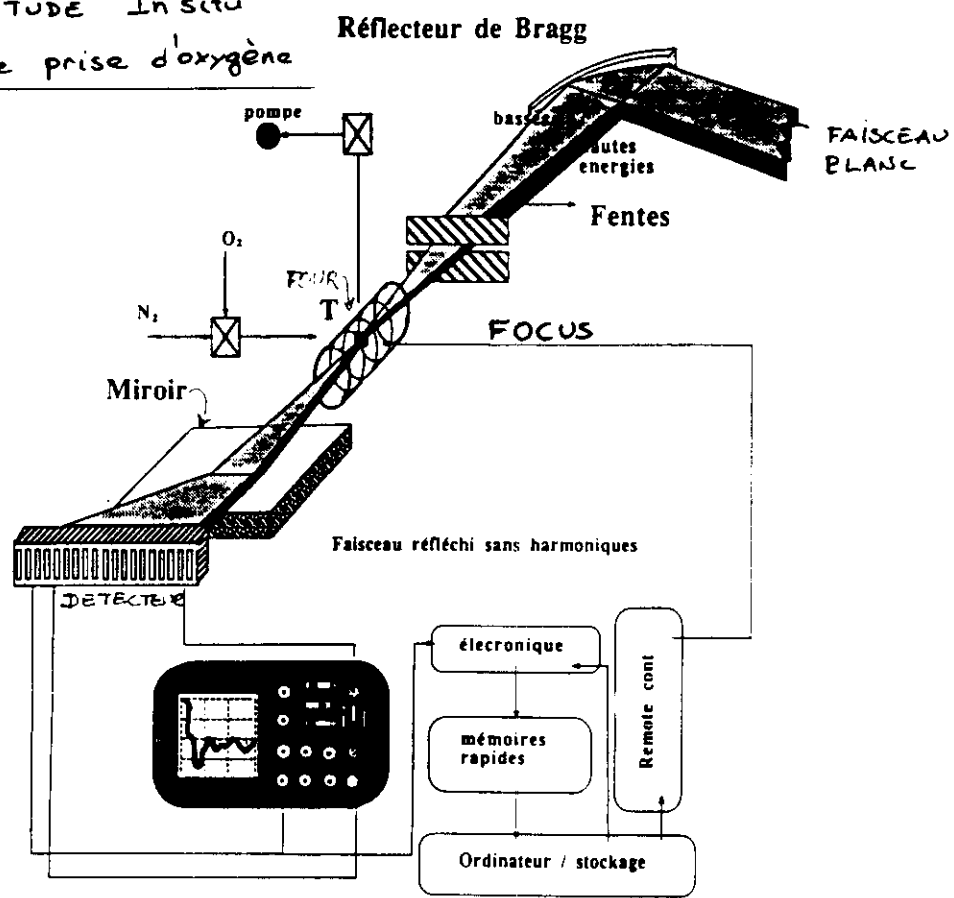


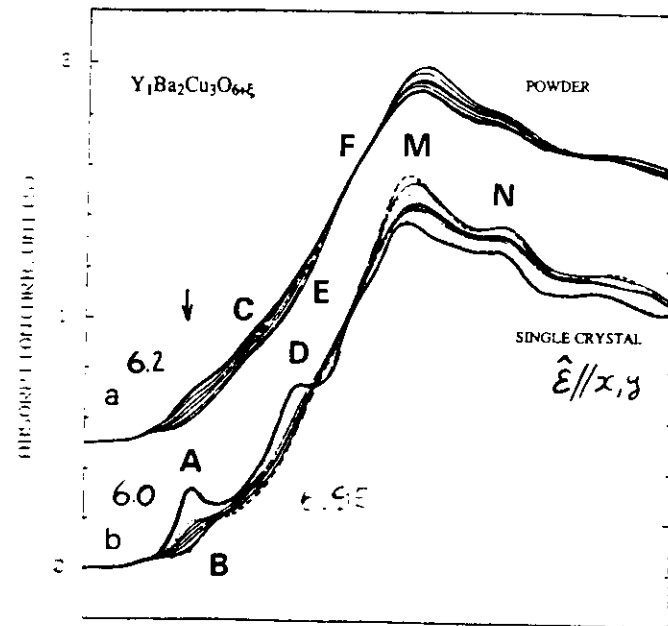
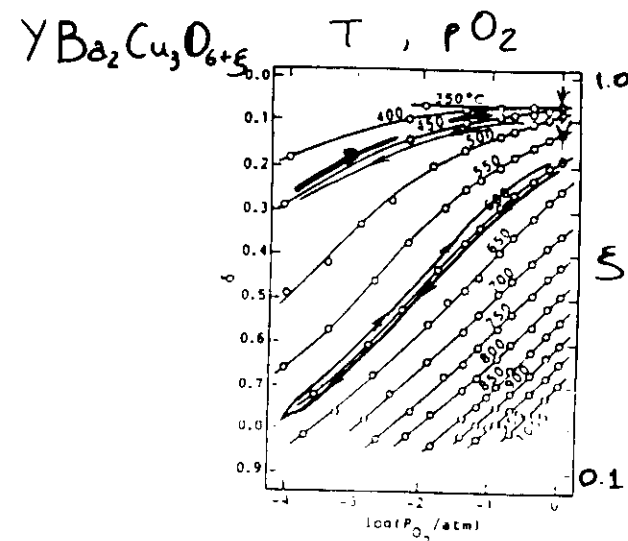
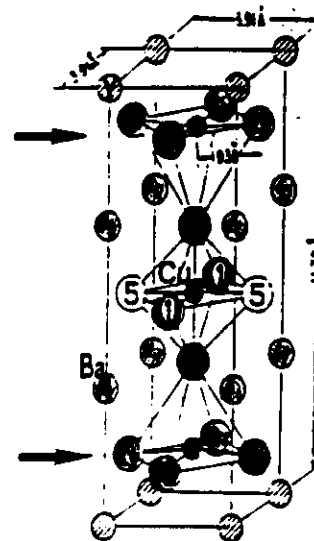
FIG. 2. The sagittally focusing double-crystal monochromator. The second crystal is shaped like an isosceles triangle with some ribs in order to prevent antilastic bending. The basis of the triangle is secured to a crystal holder and the free end can be displayed by a screw in order to realize optimum sagittal radius.

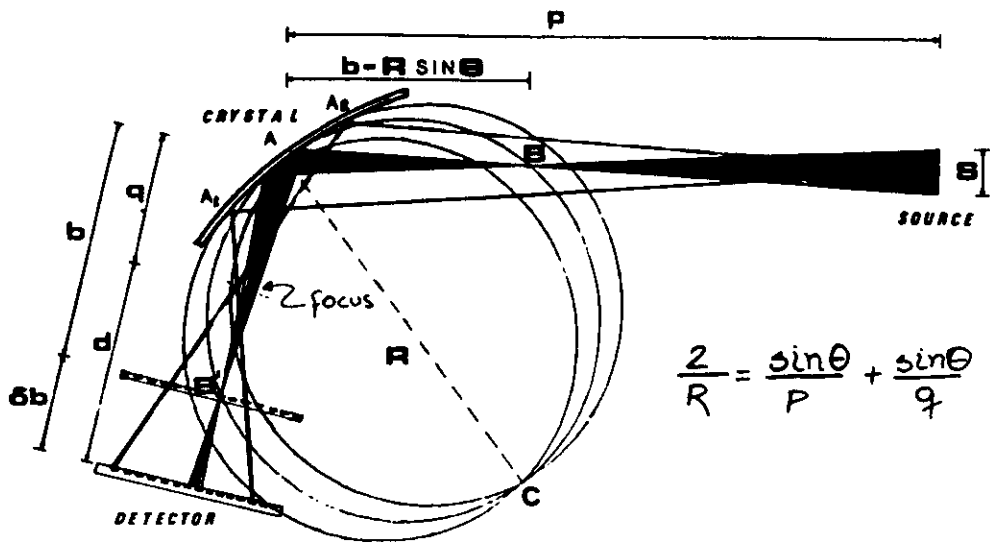


ETUDE In situ de prise d'oxygène



Description schématique
du spectromètre d'Exafs Dispersif





$$\frac{2}{R} = \frac{\sin \theta}{p} + \frac{\sin \theta}{q}$$

Resolution

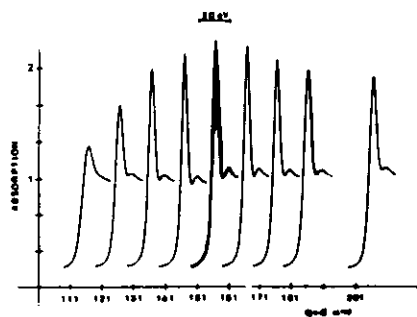
$$\delta E = E \cot \theta \delta \theta$$

- detection pixel, distance
- optics Ω
- source Rowland circle

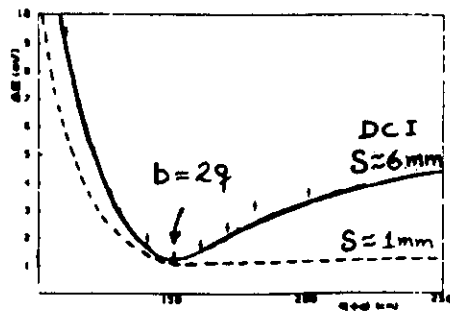
$$p \gg q \Rightarrow b \approx 2q$$

H. Tolentino et al. JAC (1987)

Resolution $\times$ detector position

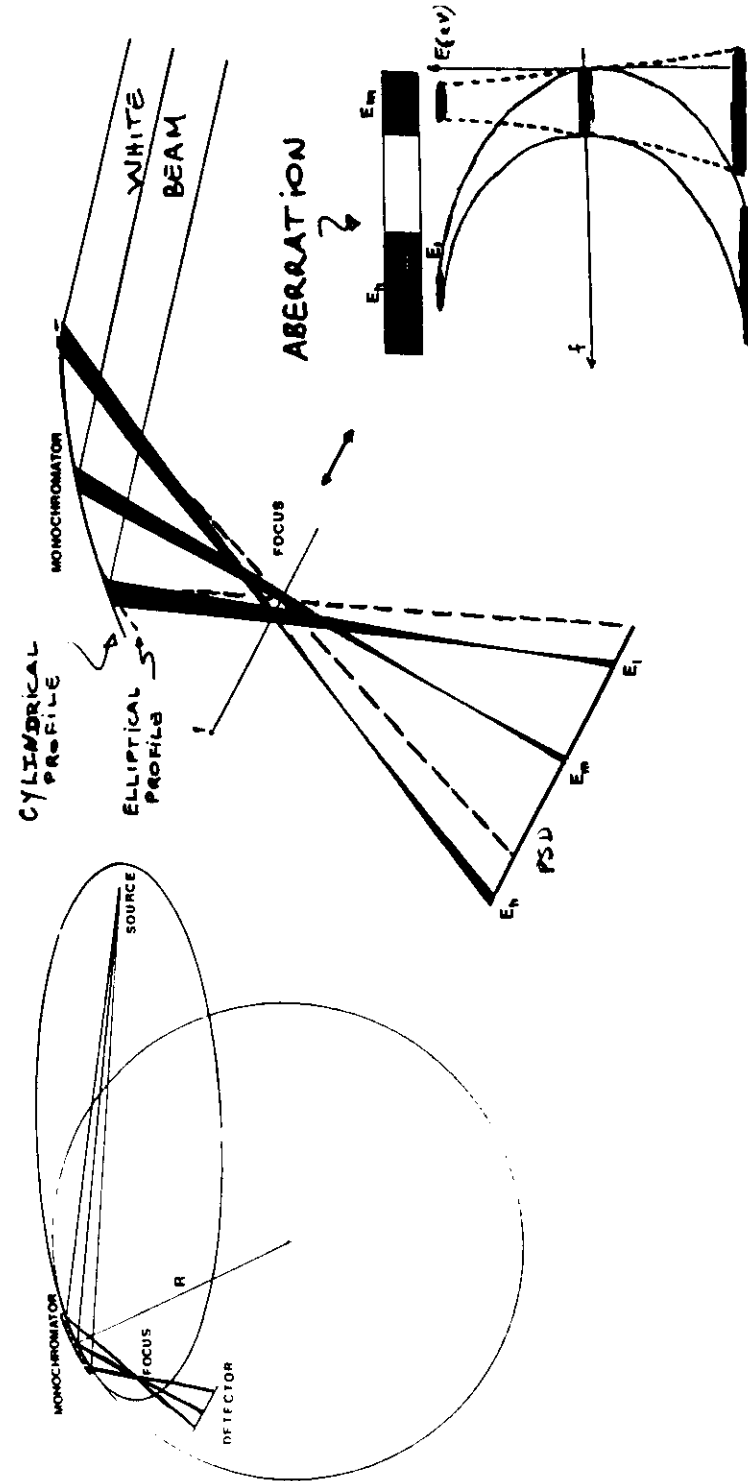


C: 344 + A: K edge (11055 eV)



field depth

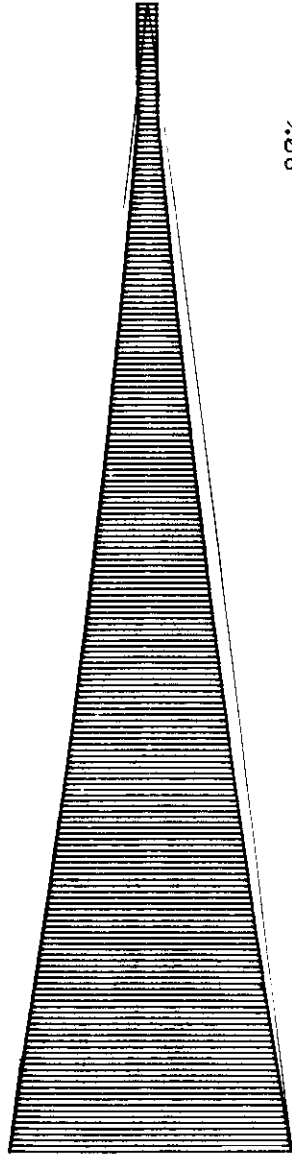
OPTICAL ABERRATION



$$\omega(x) = \frac{1}{2} \left(1 - \frac{2x}{L} \right) \Phi(x) \approx \frac{W}{2} \left(1 - \frac{2x}{L} \right) \left(\frac{1 - Kx}{1 + Kx/2} \right)$$

IDEAL ELLIPSE PROFILE

Shape optimized for energy = 9000 eV
and for focalization point = 70 cm



CRYSTAL : SILICIUM 111 (-0°)

: Lr= 230 mm
: Wr= 55 mm
: Ur= 10 mm
: Tr= 1.5 mm

: L0= 210 mm
: W0= 52 mm
: U0= 5 mm
: T0= 1.5 mm

$$\omega(x) = \frac{W}{2} \left(1 - \frac{2x}{L} \right) \Phi(x) \approx \frac{W}{2} \left(1 - \frac{2x}{L} \right) \left(\frac{1 - Kx}{1 + Kx/2} \right)$$

linear correction

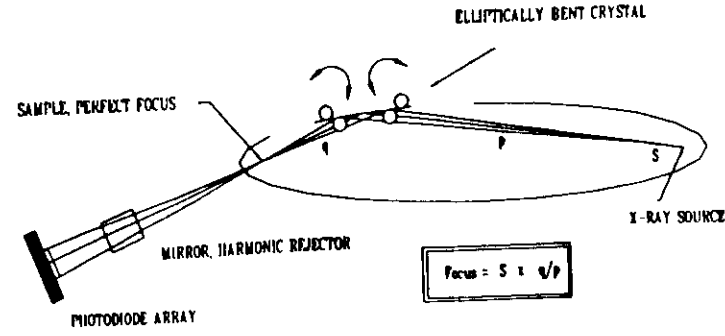
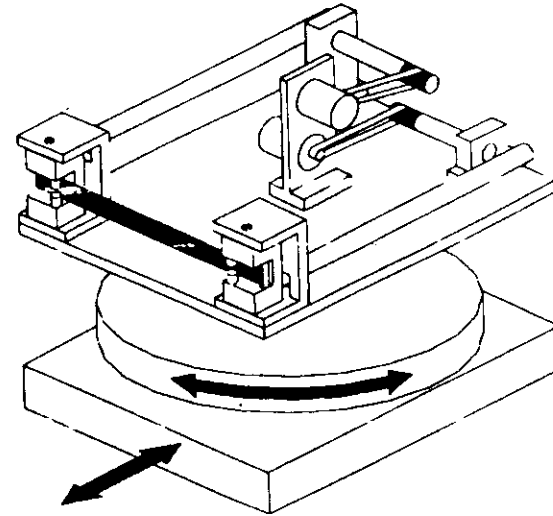
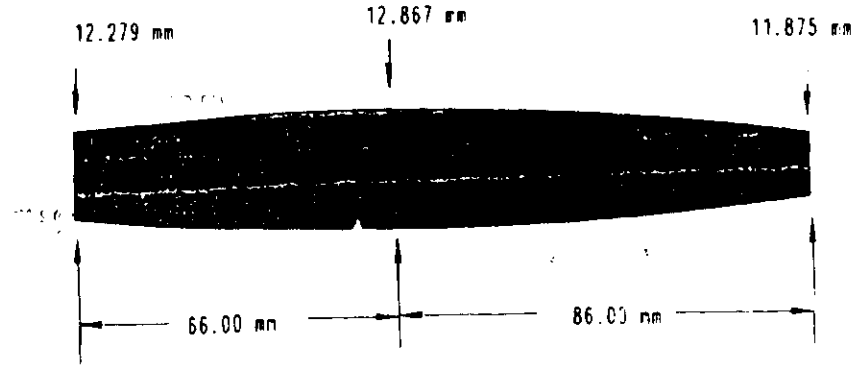


Figure 1. Schematic of dispersive XAFS geometry and components. The ideal optics requires that the source and focus be located at the foci of an ellipse. The crystal is bent to match an arc of the ellipse by a four-point bender as indicated.



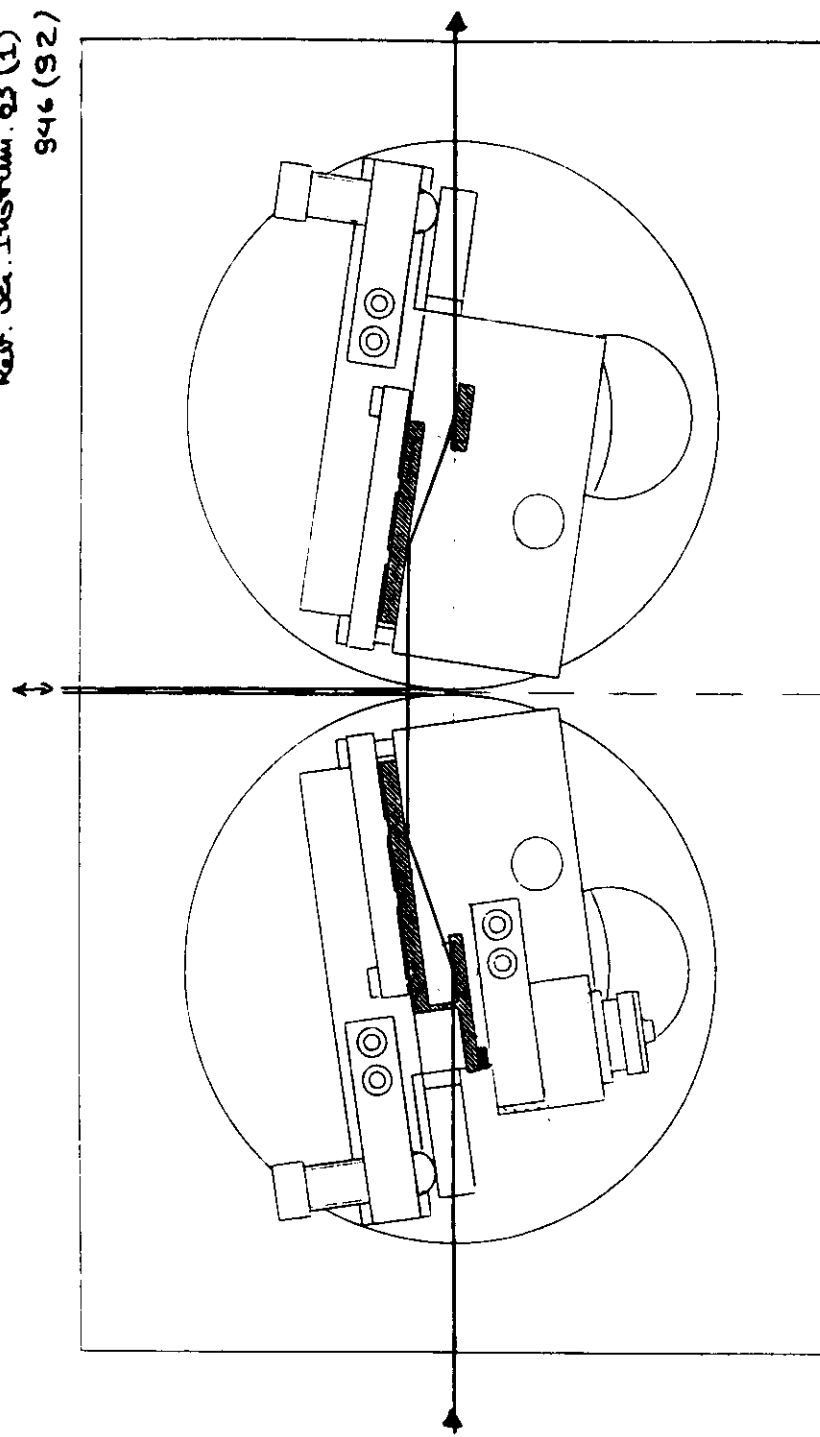
FOUR - CRYSTAL

$$\Delta\theta = \frac{\Delta X}{R}$$

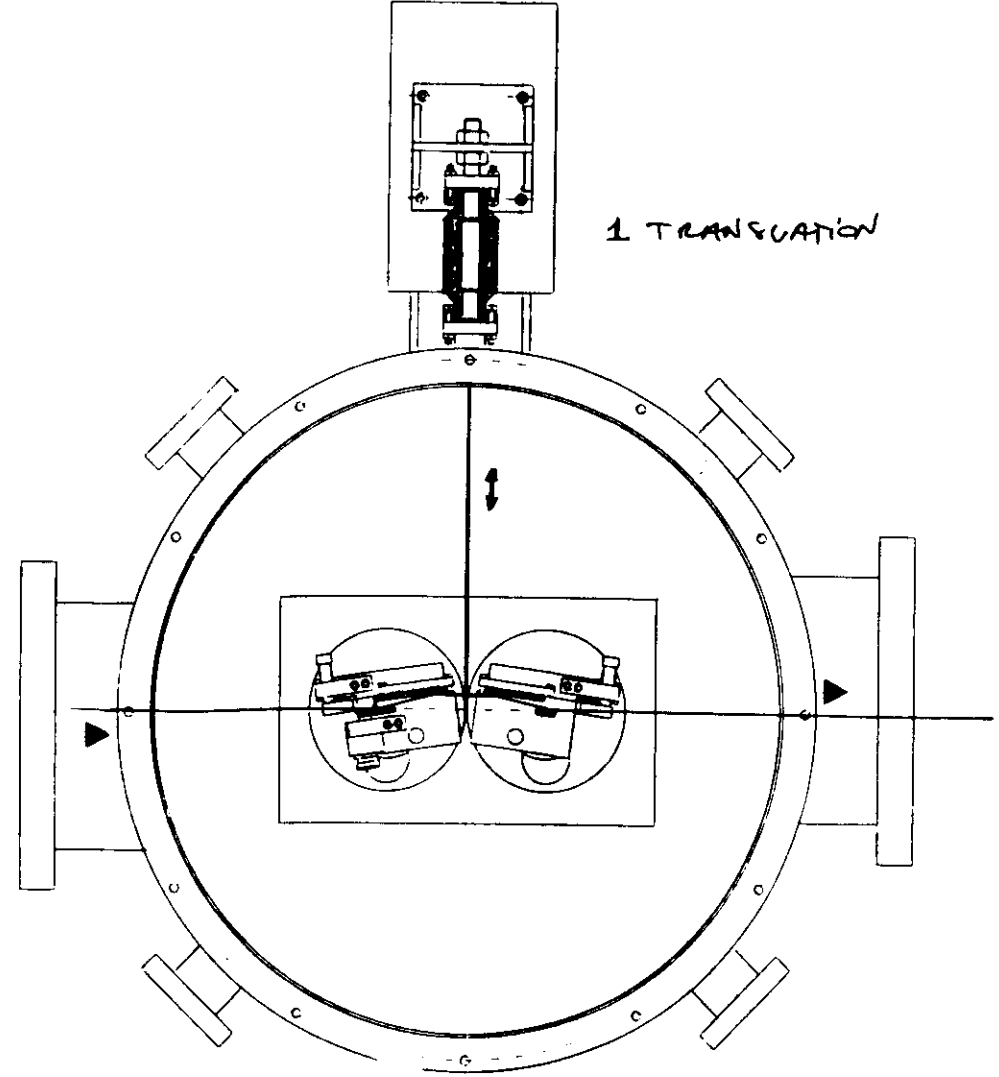
TOLentino & RODRIGUES

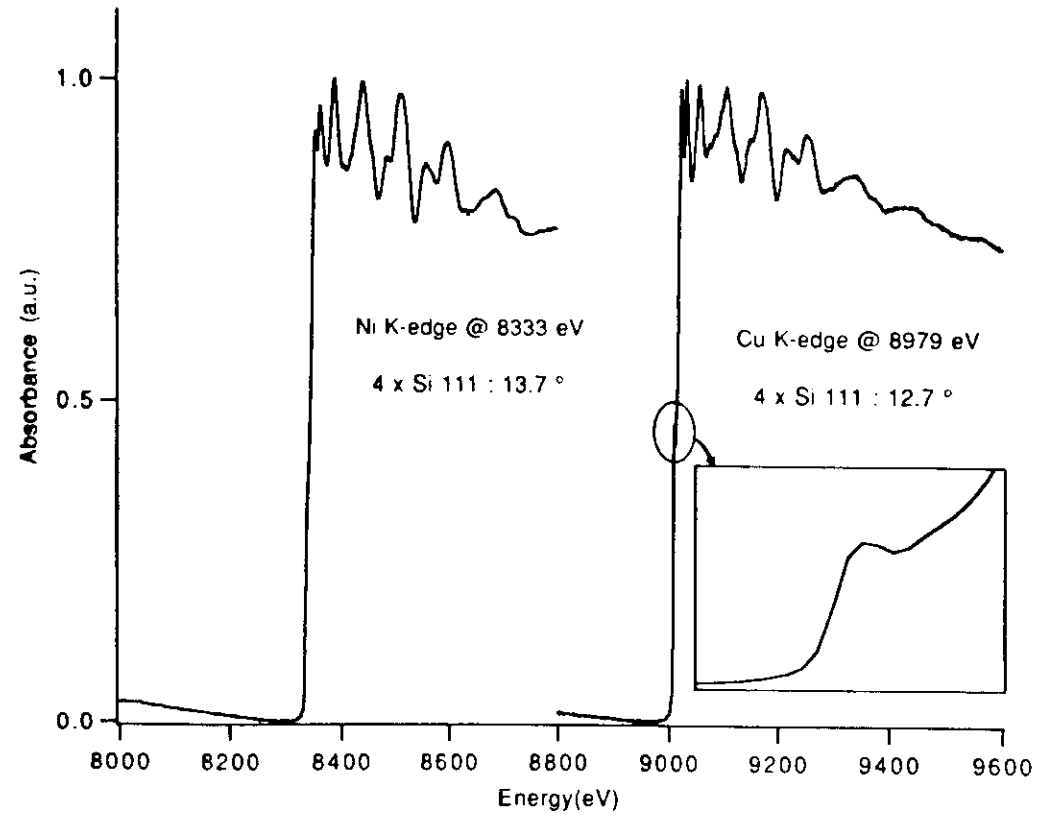
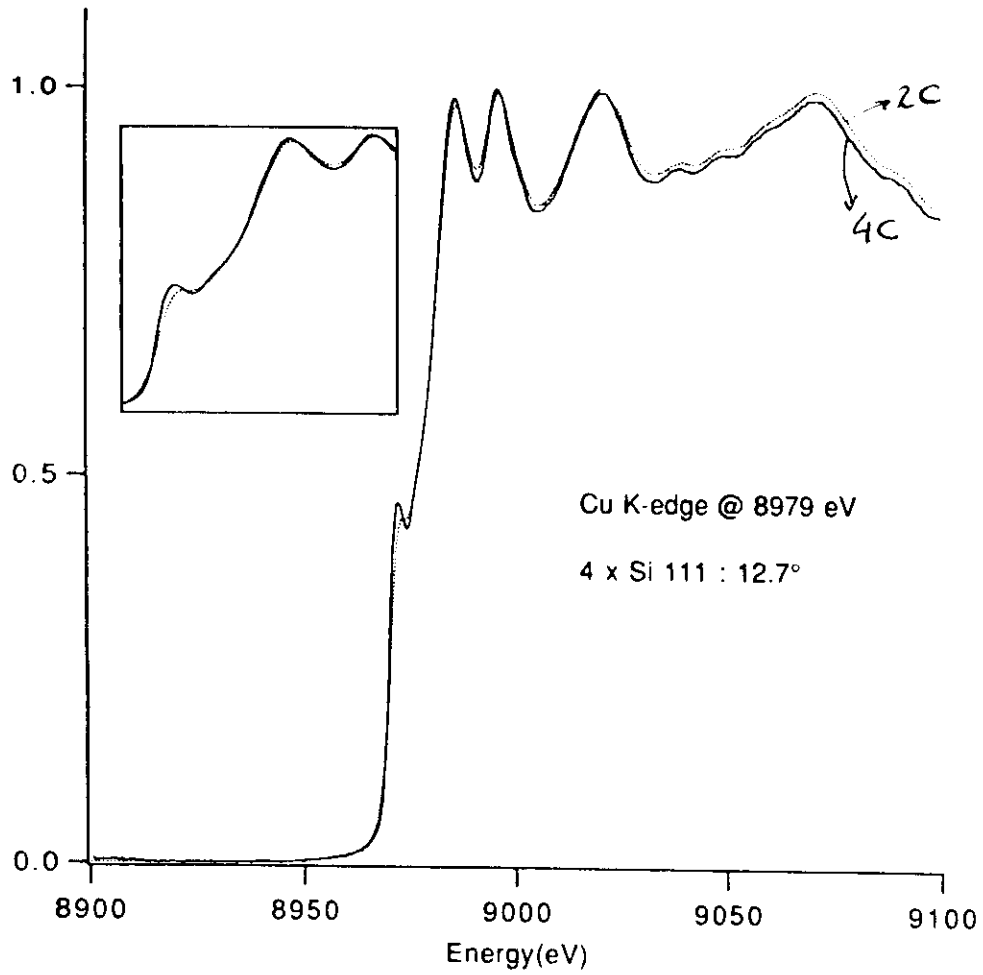
Rev. Sci. Instrum. 63 (1)

946 (92)



FOUR - CRYSTAL MONOCHROMATOR





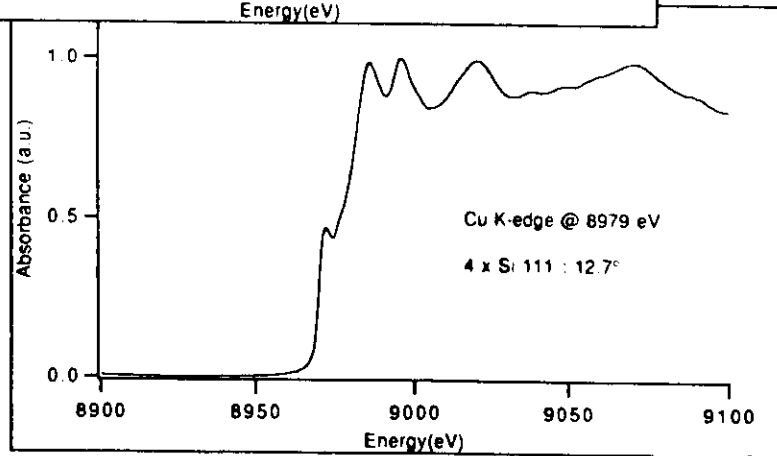
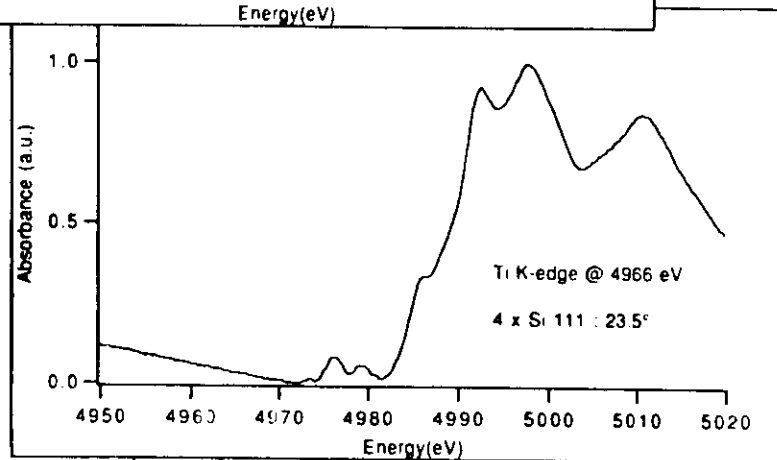
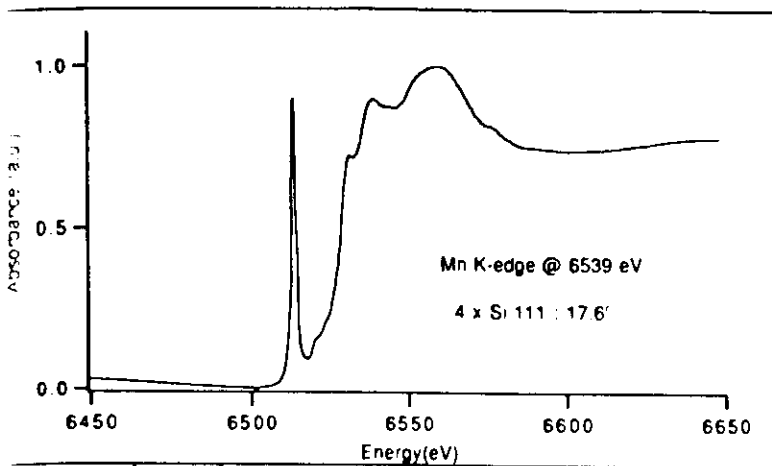
$$\alpha = 1.6 \times 10^{-4}$$

$$\beta = 6'' = 3 \times 10^{-5}$$

$$\frac{\alpha}{\beta} \approx 5$$

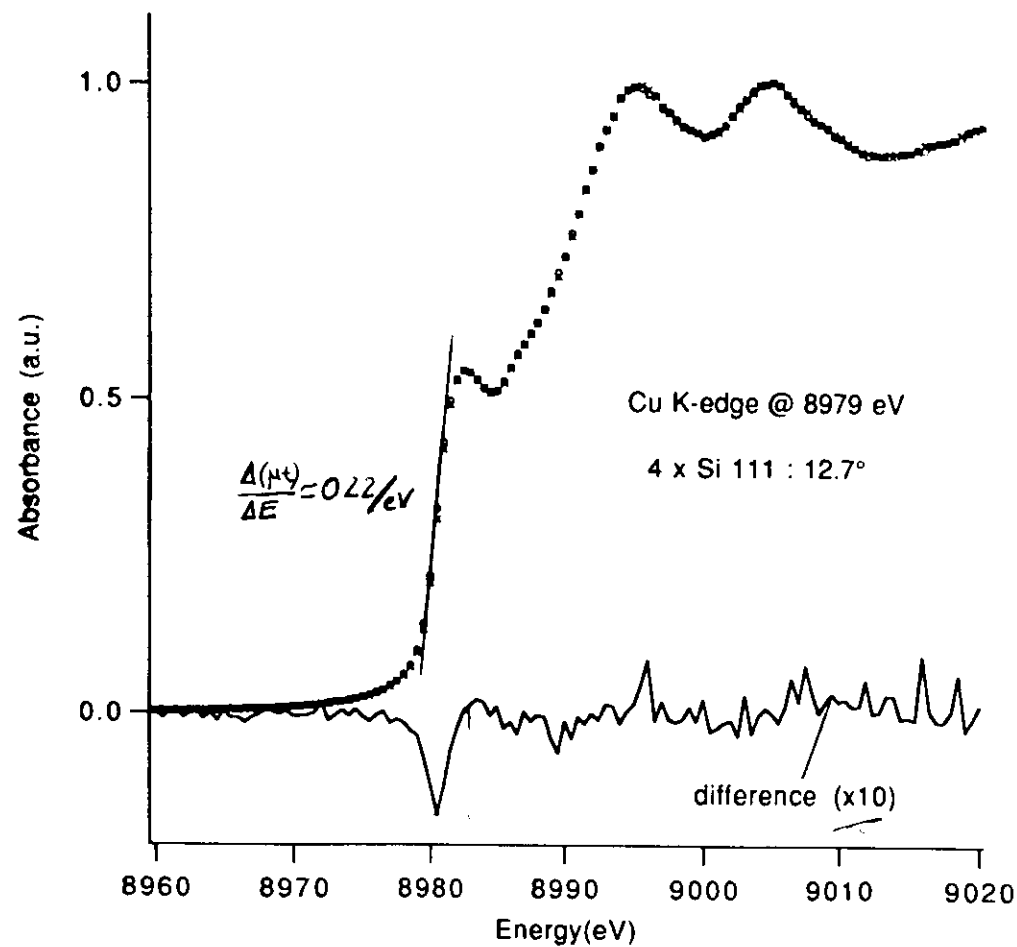
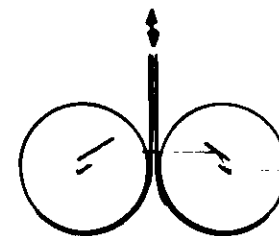
$$\frac{2C}{4C} \sim 5 \rightarrow C$$

RESOLUTION



varre_4c

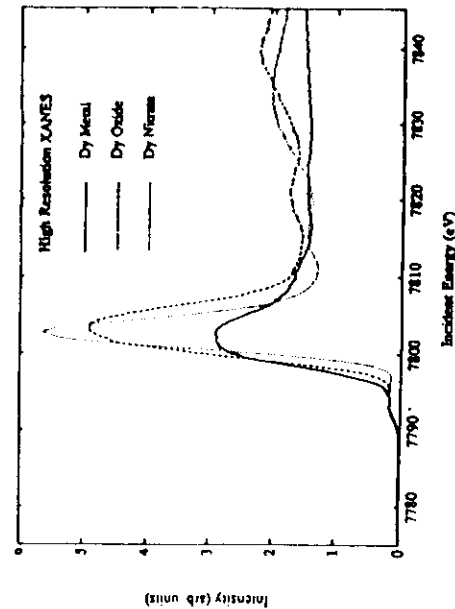
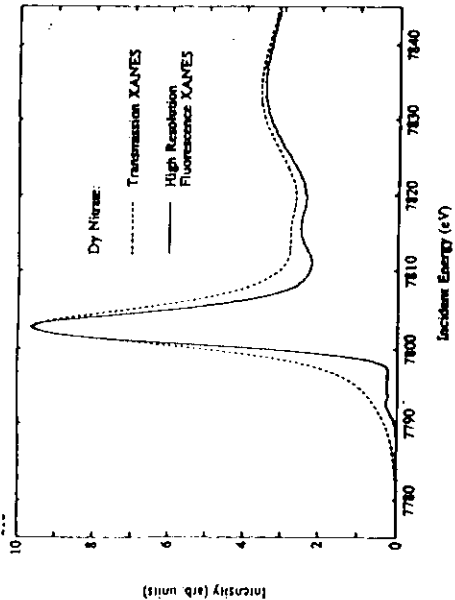
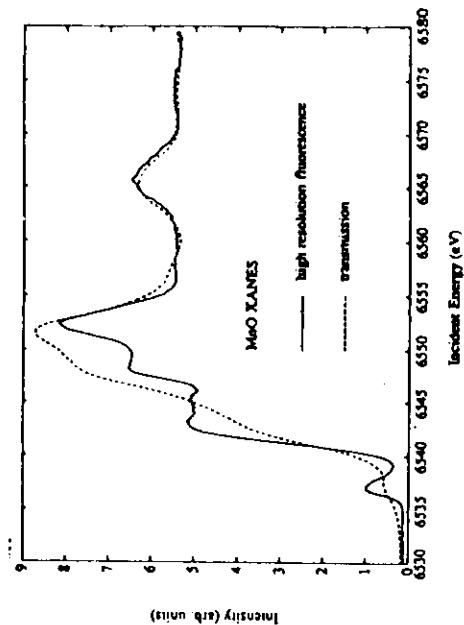
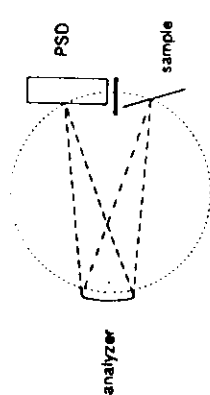
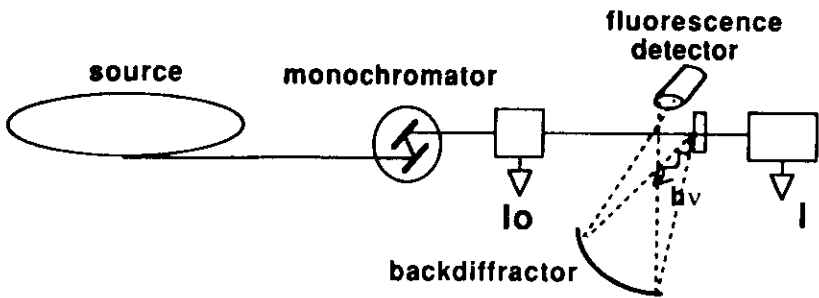
POSITION.



$$\delta E = 0.074 \text{ eV}$$

$$\frac{\Delta E}{E} = 8 \times 10^{-6} ; \Delta \theta = 2 \times 10^{-6}$$

XAS set up for High Resolution Fluorescence Detection



Section III. Beamline instrumentation: (g) Miscellaneous

PHASE-PLATE PERFORMANCE FOR THE PRODUCTION OF CIRCULARLY POLARIZED X-RAYS

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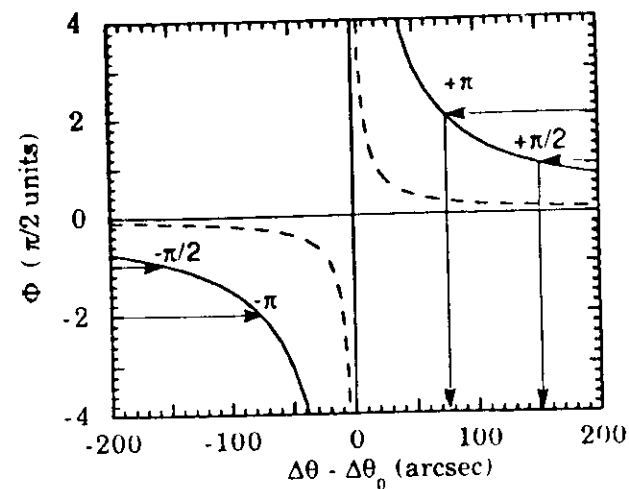
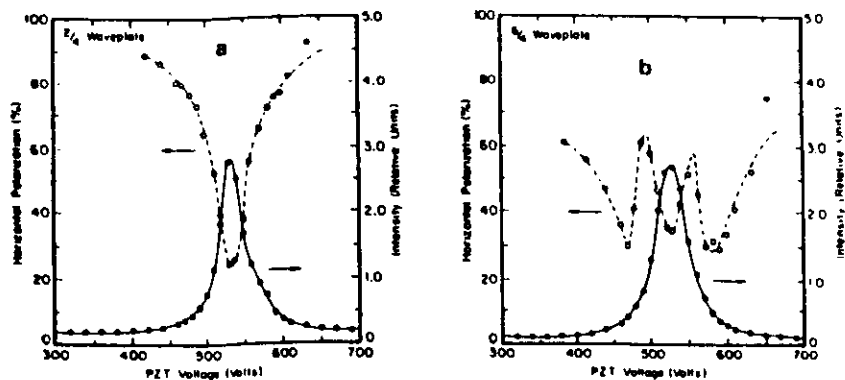
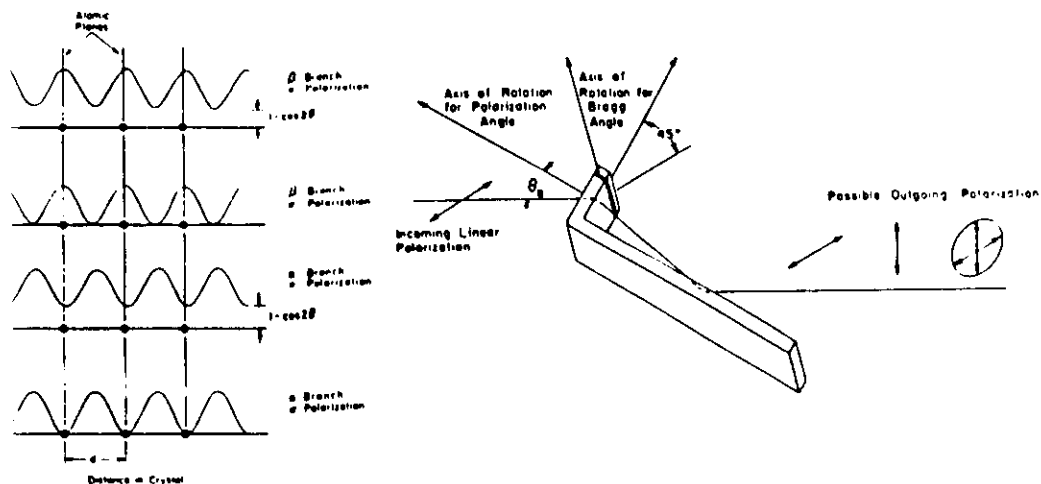


Figure 2. Calculated phase difference Φ between the σ and π components of the transmitted wave as a function of the angular offset defined in text. Calculations were done with $\lambda = 1.712 \text{ \AA}$. Full line: (111) diamond crystal of thickness $t_0 = 930 \text{ \mu m}$, (220) reflection and effective beam path $t = 1680 \text{ \mu m}$. Dotted line: (110) silicon crystal of thickness $t_0 = 62 \text{ \mu m}$, (220) reflection and effective beam path $t = 155 \text{ \mu m}$.

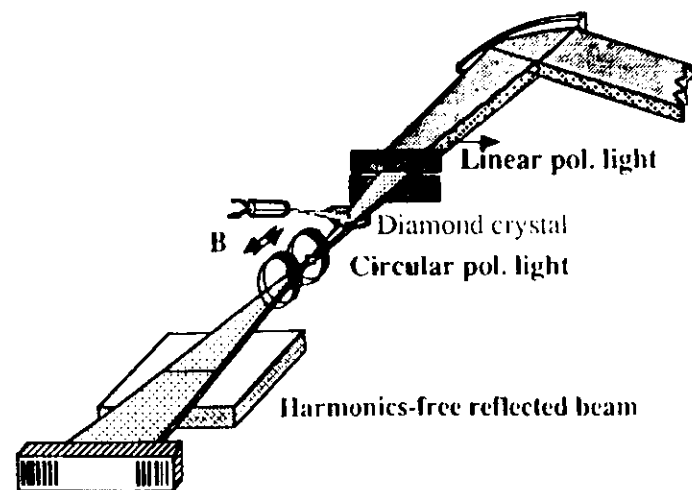


Fig. 3. Sketch of the dispersive x-ray absorption spectrometer at DCI (LURE). A diamond quarter wave plate with a diffraction plane rotated by 45° with respect to the horizontal plane produces circular polarization.

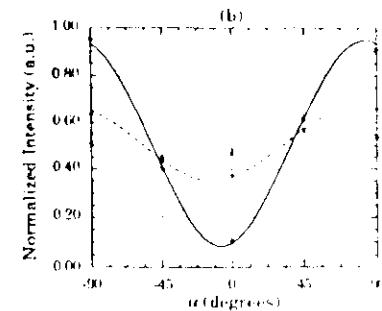
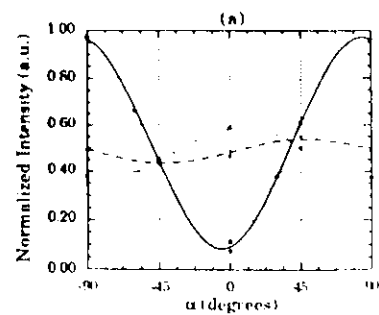
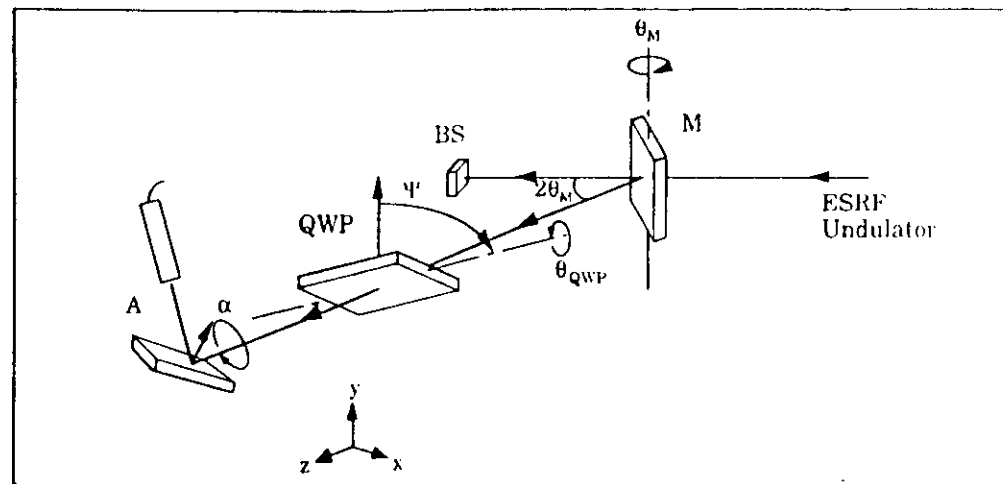
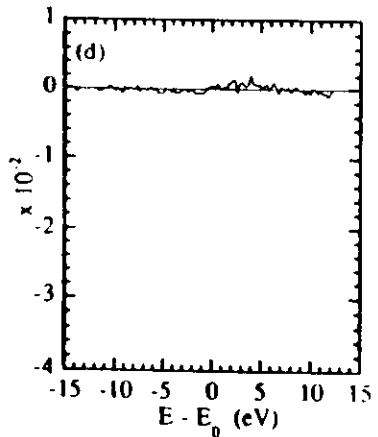
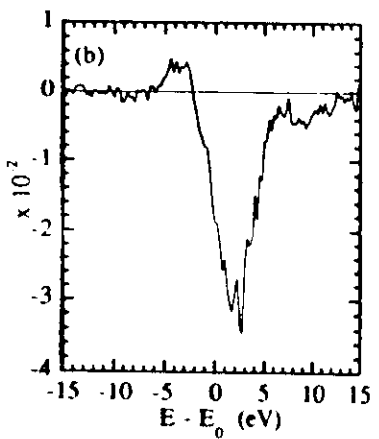
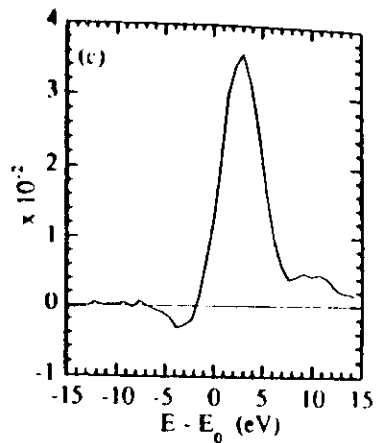
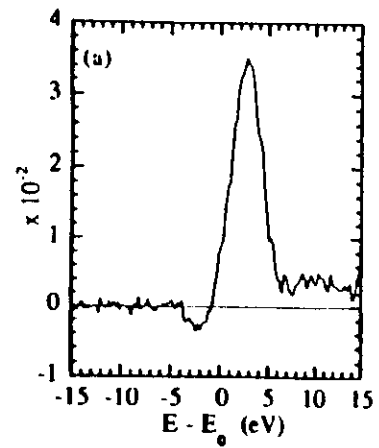


Fig. 6 Normalized integrated intensities from an Al 311 powder diffraction line as a function of the azimuthal angle α for three different positive and negative values of the angular offset from the center of the reflection profile: a) plain line: offset=105 arcsec, $P1=0.83 \pm 0.01$; dashed line: offset=170 arcsec, $P1=0.01 \pm 0.03$; dotted line: offset=195 arcsec, $P1=0.22 \pm 0.01$; b) plain line: offset=90 arcsec, $P1=0.53 \pm 0.05$; dashed line: offset=160 arcsec, $P1=0.28 \pm 0.03$; dotted line: offset=180 arcsec, $P1=0.01 \pm 0.01$.

